

Notice of References Cited	Application/Control No. 10/584,868		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Kriellion A. Sanders		Art Unit 1796	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,773,803	08-2004	Lee et al.	428/323
*	B	US-2004/0249012	12-2004	Tanaka et al.	522/083
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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*	N	JP 11335596	12-1999	Japan		(Abstract Provided)
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NON-PATENT DOCUMENTS

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	U	Derwent Abstract ACC- No: 2000-092747, JP 11335596 , December 7, 1999, pp. 1-3.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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